



PATENT
ATTY. DOCKET NO.: P68917US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Cheol Hwan PARK, et al.

Group Art Unit: 2812

Serial No.: 10/600,332

Examiner: Stanetta D. Isaac

Filed: June 23, 2003

For: METHOD FOR FORMING DEVICE ISOLATION FILM OF SEMICONDUCTOR
DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

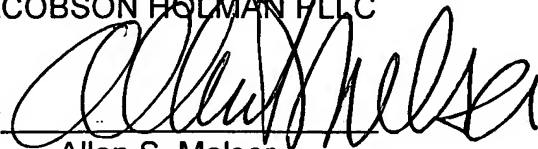
Sir:

This is a Petition for Extension of Time for a one-month period pursuant to 37 C.F.R. §1.136(a). This Petition for Extension of Time is being concurrently filed with a Request for Continued Examination (RCE). A credit card payment form in the amount of \$120.00 is enclosed with this Petition in accordance with 37 C.F.R. §1.17(a)(1)-(5). If this fee is inaccurate please debit or credit Deposit Account No. 06-1358.

Respectfully submitted,

JACOBSON HOLMAN PLLC

By


Allen S. Melser

Reg. No. 27,215

400 Seventh Street, NW
Washington, D.C. 20004-2201
Telephone: (202) 638-6666
Date: June 7, 2005
ASM:SCB

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